

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gang Bai and Chunlin Liang

Application No. 09/517,705

Filed: March 2, 2000

For: Complementary Metal Gate Electrode

Technology

Examiner: Loke, Steven Ho Yin

Art Unit: 2811

PRELIMINARY AMENDMENT

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

In connection with the filing of the Request for Continued Examination, Applicants respectfully request entry of the following amendment.